

**Preliminary Amendment**

Applicant: Werner Ertle et al.

Serial No.: Unknown

(Priority Application No. DE 102 34 648.8)

(International Application No. PCT/DE03/02544)

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Docket No. I431.124.101/FIN 404 PCT/US

Title: SEMICONDUCTOR WAFER WITH ELECTRICALLY CONNECTED CONTACT AND TEST AREAS

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**IN THE SPECIFICATION**

Please insert the following paragraph beginning at page 1, line 6, of the substitute specification with the following paragraph:

**Cross Reference to Related Application**

This Utility Patent Application claims the benefit of the filing date of German Application No. DE 102 34 648.8, filed July 29, 2002, and International Application No. PCT/DE03/02544, filed July 29, 2003, both of which are herein incorporated by reference.